

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1423	(438/975).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2009/01/12 14:16
L2	2	L1 and ("registration marker")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:17
L3	1	L2 and @ad<"20030820"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:18
L4	263	("registration marker")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:18
L5	13	L4 and (sem "scanning electron microscope" stm "scanning tunnelling microscope" "optical microscope")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:20
L6	3	L5 and @ad<"20030820"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:21
L7	126542	(sem "scanning electron microscope" stm "scanning tunnelling microscope" "optical microscope")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:22
L8	6591	L7 and ((fet "field effect transistor") (cmos "complementary metal oxide semiconductor") (mosfet "metal oxide semiconductor field effect transistor"))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:24
L9	506	L8 and ("registration marker" marker)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:24
L10	6	L9 and ("registration marker")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:25
L11	0	L10 and @ad<"20030820"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:25

1/12/2009 2:25:48 PM

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